



1746  
257/040  
P00-0022

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

James Bryer

Serial No.: 09/658,395

Filed: September 8, 2000

For: Spray Nozzle System For A  
Semiconductor Wafer Container Cleaning  
Apparatus

)  
) Group Art Unit: 1746

)  
) Examiner: Zeinab El-Arini

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
Washington, D.C. 20231

Sir:

In compliance with the Applicants' duty under 37 CFR 1.97-98, the following information is brought to the attention of the Examiner. The items are listed on the attached form PTO-1449 and copies are enclosed for the convenience of the Examiner.

The items identified in this Information Disclosure Statement may or may not be "material" pursuant to 37 CFR 1.56 and the submission thereof by Applicants shall not be construed as an admission that any such patent, publication or other information referred to therein is material or considered to be material (37 CFR 1.97(h)), or even qualifies as "prior art" under 35 U.S.C. § 102 with respect to this invention unless specifically designated by Applicants as such.

CERTIFICATE OF MAILING  
(37 C.F.R. §1.8a)

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as First Class Mail in an envelope addressed to the Commissioner for Patents, Washington, D.C. 20231.

May 2, 2002  
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Signature of Person Mailing Paper  
Laura Murphy

The filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information, as defined in 37 CFR 1.56, exists.

**STATEMENT UNDER 37 CFR § 1.97(e)(1):**

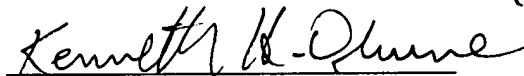
Each item contained in this IDS was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this IDS.

Applicant believes that no fee should be required for consideration of this Information Disclosure Statement. Should Applicant be in error, however, please charge any fee required for the consideration of this paper to Deposit Account No. 12-2475.

Respectfully submitted,

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By:



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Date: May 7, 2002

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